



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Doak et al. : Group Art Unit: 2822  
Serial No.: 09/887,777 : Examiner: Parviz Hassanzadeh  
Filed: June 22, 2001 :  
Title: Method and Apparatus for Preparing Nitride Semiconductor Surfaces

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**LETTER TO OFFICIAL DRAFTSPERSON**

Subject to the approval of the examiner in charge of this application, please substitute the accompanying new sheet 1/2 for that currently appearing in the application. A further copy is enclosed showing in red the correction made.

Respectfully submitted,

Date: 2/14/03

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